



**SDI Review Form 1.6**

Journal Name:	<b><u>Physical Science International Journal</u></b>
Manuscript Number:	<b>Ms_PSIJ_33788</b>
Title of the Manuscript:	<b>Deposition of Silicon Films from Liquid Cyclopentasilane Precursors Using High Pressure Spray System</b>
Type of the Article	

**General guideline for Peer Review process:**

This journal's peer review policy states that **NO** manuscript should be rejected only on the basis of '**lack of Novelty**', provided the manuscript is scientifically robust and technically sound.

To know the complete guideline for Peer Review process, reviewers are requested to visit this link:

(<http://www.sciencedomain.org/page.php?id=sdi-general-editorial-policy#Peer-Review-Guideline>)



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**PART 1: Review Comments**

	Reviewer's comment	Author's comment <i>(if agreed with reviewer, correct the manuscript and highlight that part in the manuscript. It is mandatory that authors should write his/her feedback here)</i>
<b>Compulsory</b> REVISION comments	<b>Update references to current article. Most of those given are too old to be trusted with current trends in research</b>	References for CPS were updated. 3 papers more cited, which were published in 2016 and 2017. In the 70ties to 90ties basic research on Si deposition from silanes were published in highly ranked journals. In this paper, the papers for the IR-bands of these films were used for assigning the found IR-bands which was successful. Updated paper for such bands do normally no more report details which are already published in these papers.
<b>Minor</b> REVISION comments	Reference should be in italics and <i>et al.</i> not et al.	et al. was set to italics
<b>Optional/General</b> comments	Its a good paper but needs minor corrections.	